

An ellipsometer measures a change in the polarization state of light, an amplitude ratio  $(\psi)$  and the phase difference  $(\Delta)$ , as a result of interaction with materials. By fitting  $\psi$  and  $\Delta$  to existing models, material properties such as optical constants (n, k), the thickness of thin films, and other material parameters can be determined.



- 6. Click on the 'Measurement' button
- 7. Data and analysis results appear.
- 8. Shut down the system

## CompleteEASE



## Measurement accuracy

Thickness

Uniformity

Results

TEXAS A&M ENGINEERIN EXPERIMENT STATION

SiO <sub>2</sub> thickness (nm)	Std. Dev., n=30 (nm)
2	±0.01
25	±0.01
60	±0.01
120	±0.006
500	±0.025
1000	±0.05